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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 09/905,286
Filing Date July 13, 2001
Inventor.... Cem Basceri et al.
Assignee.... Micron Technology, Inc.
Group Art Unit.... 1762
Examiner Fuller, Eric B.
Attorney's Docket No. MI22-1724
Title: Chemical Vapor Deposition Methods of Forming Barium Strontium Titanate
Comprising Dielectric Layers

RESPONSE TO APRIL 30, 2002 FINAL OFFICE ACTION TO ACCOMPANY RCE FILING

To: Box RCE
Assistant Commissioner for Patents
Washington, D.C. 20231

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AMENDMENTS

RECEIVED
AUG 02 2002
TC 1700

In the Claims

Please replace the indicated claims with the following clean versions of the claims, in accordance with 37 C.F.R. § 1.121(c)(1)(i). Cancel all previous versions of any indicated claim. A marked up version showing amendments to any claims being changed is provided in one or more accompanying pages separate from this amendment in accordance with 37 C.F.R. § 1.121(c)(1)(ii). Any claim not accompanied by a marked up version has not been changed relative to the immediate prior version, except that marked up versions are not being supplied for any added claim or canceled claim.